

APR 26 2005

LAW OFFICES OF
McGINN & GIBB, PLLC
A PROFESSIONAL LIMITED LIABILITY COMPANY
PATENTS, TRADEMARKS, COPYRIGHTS, AND INTELLECTUAL PROPERTY LAW
8321 OLD COURTHOUSE ROAD, SUITE 200
VIENNA, VIRGINIA 22182-3817
TELEPHONE (703) 761-4100
FACSIMILE/DATA: (703) 761-2375; 761-2376
E-MAIL: MCGINN&GIBB@AOL.COM

SEAN M. MCGINN
PHILLIP E. MILLER*
FREDERICK E. COOPERRIDER*
JAMES E. HOWARD*
JAMES N. DRESSER
JOHN J. DRESCH
SCOTT M. TULINO
J. BRADLEY WRIGHT*
*MEMBER OF BAR OTHER THAN VA

ANNAPOLIS, MD OFFICE
FREDERICK W. GIBB, III
MOHAMMAD S. RAHMAN*
PAMELE M. RILEY*

April 26, 2005

VIA FACSIMILE
EXPEDITED PROCEDURE

To: Examiner Julio Maldonado
Group Art Unit No. 2823
U. S. P. T. O.

Facsimile No. 703-872-9306

From: Phillip E. Miller

Facsimile No. 703-761-2375

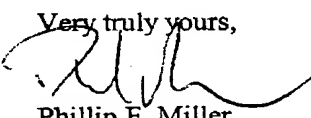
Re: Filing of Amendment
U. S. Patent Application Serial No. 09/851,313
Our Ref: WAK.084

Dear Examiner:

Enclosed please find an Amendment which is filed in response to the non-final Office Action dated January 26, 2005, and which should place this Application in condition for allowance.

Thank you in advance for your kind consideration of this case.

Very truly yours,


Phillip E. Miller

PEM/lmb
Enclosure

APR 26 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tatsuya Usami

Serial No.: 09/851,313

Group Art Unit: 2823

Filed: May 9, 2001

Examiner: Maldonado, Julio J.

For SEMICONDUCTOR DEVICE AND SEMICONDUCTOR WAFER HAVING A
MULTI-LAYERED INSULATION FILM

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Final Office Action dated **January 26, 2005**, please amend the
above-identified application as follows: